

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)			ATTY DOCKET NO. 35.C14089		APPLICATION NO. 09/443,308	
<div style="border: 2px solid black; border-radius: 50%; padding: 10px; display: inline-block;"> OFFICE JUL - 6 2000 PATENT & TRADEMARK OFFICE </div>			APPLICANT TOSHIKI AIBA ET AL.			
			FILING DATE Nov mb r 19, 1999		GROUP 2879	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JW	6,008,569	12/28/99	Yamanobe	313	310	10/30/97
JW	6,005,334	12/21/99	Mitome et al.	313	309	4/28/97

FOREIGN PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
JW	7-235255	9/5/95	Japan			Abstract
JW	2836015	10/9/98	Japan			Abstract
JW	2903295	3/26/99	Japan			Abstract
JW	0 701 265	3/13/96	EPO			
JW	0 660 357	6/28/95	EPO			

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
JW	C.A. Mead, "Operation of Tunnel-Emission Devices", Journal of Applied Physics, April 1961, pp. 646-652.
JW	M.I. Elinson et al., "The Emission of Hot Electrons and The Field Emission of Electrons From Tin Oxide", Radio Engineering and Electronic Physics, July 1965, pp. 1290-1296.
JW	H. Araki, "Electroforming and Electron Emission of Carbon Thin Films", Journal of the Vacuum, Society of Japan, 1983, pp. 22-29 (with English Abstract on page 22).
JW	G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, 9, 1972, pp. 317-328.
JW	M. Hartwell, "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", IEDM, 1975, pp. 519-521.
JW	C.A. Spindt, "Physical Properties of Thin-Film Emission Cathodes with Molybdenum Cones", J. Applied Physics, Vol. 47, No. 12, December 1976, pp. 5248-5263.
JW	J. Dyke et al., "Field Emission", Advances in Electronics and Electron Physics, Vol. VIII, 1956, pp. 89-185.

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Joseph Williams

5/1/03

Sheet 1 of 1

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U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
JW	6,179,678	1/30/01	Kishi et al.			2/4/99	
JW	6,097,138	8/1/00	Nakamoto			9/18/97	
JW	6,246,168	6/12/01	Kishi et al.			7/28/95	

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	
JW	8-321254	12/96	Japan			Abstract	
JW	10-149760	6/96	Japan			Abstract	

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)		

EXAMINER <i>Joseph Williams</i>	DATE CONSIDERED <i>5/1/03</i>
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Sheet 1 of 1